

Surface Morphology, Structural and Optical Properties of MgO Films Obtained by Spray Pyrolysis Technique

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X-ray diffraction, atomic force microscopy, field emission scanning electron microscopy, UV-visible photometry, and photoluminescence measurements were used to investigate the surface morphology and structural and optical properties of MgO films. Magnesium oxide films deposited by the spray pyrolysis technique were studied. The substrate temperature was varied from $T_s = 643$ K to 693 K. Magnesium chloride hexahydrate ($\text{MgCl}_2 \cdot 6\text{H}_2\text{O}$), dissolved in deionized water, was used as the precursor solution. It was established that the single phase films crystallize into a cubic structure with very fine crystallite size (about 2 nm). The optical band gaps of the samples were varied from 3.64 eV to 3.70 eV. Also, the films have a high level of transmittance of 90%. Photoluminescence spectra show the emission peaks at approximately 412 nm (3.00 eV) and 524 nm (2.38 eV). The peak with the energy of 3.00 eV is ascribed to holes trapped in magnesium ion vacancies acting as acceptors (F^+ center). The broad emission peak at 524 nm is related to the presence of defects (F^- centers) associated with oxygen ion vacancies.

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1. Introduction

Recently, wide band gap metallic oxides materials (SnO_2 , In_2O_3 , ZnO , CuO_2 , etc.) are increasingly used in so-called transparent electronics [1]. MgO is a promising material for application in photovoltaics and opto- and microelectronics. It is attracting much interest owing to its unique properties such as a high dielectric constant (≈ 9.8), a large band gap of 7.3–7.8 eV, and a high breakdown field of 12 MV/cm [2]. Other important properties of MgO include chemical inertness, high electrical insulation, optical transparency, high-temperature stability, and high thermal conductivity [2, 3]. Such properties allow using this compound as a dielectric material to replace silicon dioxide in some applications [2]. MgO can also be used as a protective layer of plasma display panels to extend the service life of such panels through high durability and improved discharge characteristics [4–6]. Magnetic tunnel junctions (MTJ), where MgO is used as a barrier layer, are of great importance not only for the creation of microelectronic and spintronic devices but also to clarify the mechanisms of spin-dependent tunneling of electrons [7]. MgO as an insulating layer has played a significant role in the development of magnetic data storage devices such as nonvolatile magnetic random access memories (MRAM) [8, 9]. The window layer of $\text{Zn}_{0.7}\text{Mg}_{0.3}\text{O}$ solid solution is also considered as the optimal material for SnS-based solar cells [1].

MgO thin films can be obtained using the following methods: metalorganic molecular beam epitaxy [10], metalorganic chemical vapor deposition [11], pulsed laser

deposition [12], reactive sputtering [5], chemical vapor deposition [13], sol-gel synthesis [14], spray pyrolysis [15], etc. Because of its simplicity, low cost, high-speed deposition and the possibility of obtaining films on large area substrates using various precursors, the spray pyrolysis is an effective non-vacuum method for obtaining high-quality thin films of oxides. This method allows preparing both thin and thick films. Moreover, the produced films are homogeneous and stable with time and temperature [8].

Studies of different structural and physical properties of magnesium oxide films have been reported previously [2, 3, 5, 11, 13, 14, 16–19]. But only a few studies have dealt with films obtained by the spray pyrolysis method [8, 17, 20–22]. Moreover, only one research group has reported results of an investigation of thin films obtained at substrate temperature 503 K from a solution based on magnesium chloride [22]. In this work, we present a comprehensive study of the effect of deposition temperature on the surface morphology and structural and optical properties of the films synthesized from a solution of magnesium chloride in a wider temperature range.

2. Experimental details

Magnesium oxide thin films were obtained by spray pyrolysis using the laboratory system described in [15]. For sample preparation, glass substrates of 1 mm in thickness were ultrasonically cleaned for 6 min and then washed with deionized water and ethanol. As the precursor, 0.2 molar solution of magnesium chloride $\text{MgCl}_2 \cdot 6\text{H}_2\text{O}$ (Kvalitet Chemical NPP, purity 99.98%) obtained by dissolution in deionized water under constant stirring, was used. The precursor solution was sprayed using a jet

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nozzle onto a heated substrate using air as the carrier gas. The diameter of the nozzle was 0.2 mm. The distance between the nozzle and the heated substrate surface was 15 cm. The spraying rate was 2 cm³/min, and the volume of sprayed solution 2 cm³ per sample. The substrate temperature was varied from $T_s = 643$ K to 693 K with a step of 10 K. The substrate temperature during the deposition was monitored using a chromel–alumel thermocouple located on the backside of the glass substrate.

The thickness of the samples was determined using a Dektak XT profiler. The measurements were carried out relative to the area of the substrate without a magnesium oxide layer. The measurement parameters were: scan length of 3000 μm , resolution of 0.001 μm , stylus force of 3 mg, and stylus scan range of 65.5 μm .

A field emission scanning electron microscope (FE-SEM; JEOL JSM-7600F) was used to investigate the morphology of the obtained layers. The surface morphology was probed using an atomic force microscope (AFM; NT-MDT NTEGRA Spectra). The scan area was 50 \times 50 μm^2 . The non-contact mode was used during the measurements. The root mean square (RMS) roughness of the surface was calculated using the AFM data analysis software Gwyddion [23]. An X-ray diffractometer (DRON 4-07) was used to determine the structural properties. All measurements were carried out using Ni-filtered K_α radiation of copper anode ($U = 30$ kV, $I = 20$ mA) in a 2θ angle range from 20° to 80°, where 2θ is the Bragg angle in the continuous registration mode (speed of 1°/min at 0.02 degree steps). The focusing Bragg–Brentano geometry was used in the studies. XRD patterns were normalized to the intensity of the (200) peak of the cubic MgO phase. Experimental results were transferred directly into the DifWin software (Etalon PTC, Ltd., Moscow, Russian Federation) for data analysis. The accuracy of determination of the lattice constant of the material was 0.001%. The method of determining the basic structural characteristics of the films of A_2B_6 compounds is described in detail in [24].

The optical properties of the films were examined in the wavelength range of 320–1000 nm by using a spectrophotometer (UV-Vis 721G). The photoluminescence measurements were carried out at room temperature using a He–Cd laser (wavelength 325 nm) as the excitation source. A laser beam with a power of ≈ 4 mW was focused on a line of ≈ 5 mm \times 50 μ using a cylindrical lens in a quasi-backscattering configuration. A Jobin-Yvon TRIAX iHR-550 spectrometer (300 grooves/mm, blazed at 600 nm) with a slit width of 0.1 mm was used to disperse the signal. The signal was detected with a liquid-nitrogen-cooled back-illuminated charge-coupled-device (CCD) detector array.

3. Results and discussion

SEM images of the obtained thin films are shown in Fig. 1. It can be seen that the films have a polycrystalline structure and relatively high surface roughness. The inset of Fig. 1 shows the typical profile of the film surface

obtained using the Dektak profiler. The film thickness of MgO was in the range of $d \approx 0.1$ μm as summarized in Table I.

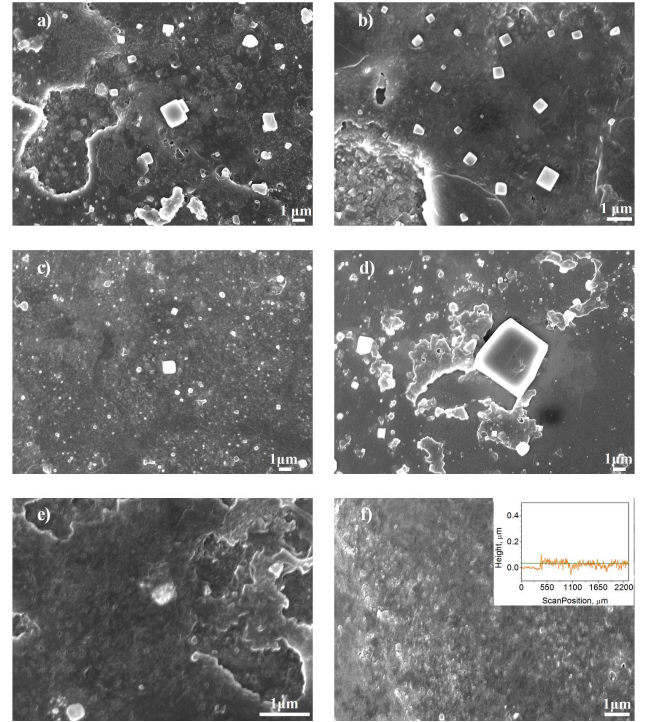


Fig. 1. FE-SEM images of samples obtained at T_s [K]: 643 (a), 653 (b), 663 (c), 673 (d), 683 (e), and 693 (f). (Inset) A typical profile of the film surface obtained using Dektak profiler.

TABLE I

Characteristics of MgO films.

T_s [K]	d [nm]	R_a [nm]	R_q [nm]	f [arb. u.]	a [nm]	L [nm]	ε $\times 10^3$	E_g [eV]
643	119.5	26.2	33.7	2.6	0.42154	42.8	2.75	3.57
653	109.3	18.4	23.1	2.4	0.42214	27.9	1.89	3.38
663	109.7	13.2	16.7	3.0	0.42270	16.2	1.91	3.69
673	105.3	15.1	19.1	2.8	0.42206	29.6	3.19	3.64
683	97.6	23.5	29.9	2.9	0.42196	40.7	4.35	3.68
693	85.3	12.2	15.6	3.6	0.42161	40.7	4.35	3.70

As follows from Fig. 1 the MgO films were nanostructured. With increasing substrate temperature, the crystallite size increased from 1 μm at 643 K to 200 nm at 673 K. In some cases, much larger crystals with a shape typical for substances with a cubic crystal lattice were detected. These data are confirmed by the AFM images of the film surface as shown in Fig. 2. It can be seen that the films have a homogeneous surface with tightly packed grains. The inset of Fig. 2 shows a typical profile of the film surface obtained by using AFM. The average surface roughness R_a and the root-mean-square roughness R_q were calculated for quantitative estimation of the surface roughness. The corresponding results are presented

in Table I. The film roughness depends on the substrate temperature. It was found that increasing the substrate temperature from $T_s = 643$ K to $T_s = 663$ K leads to reduced surface roughness. With further increase of T_s , both R_a and R_q increase.

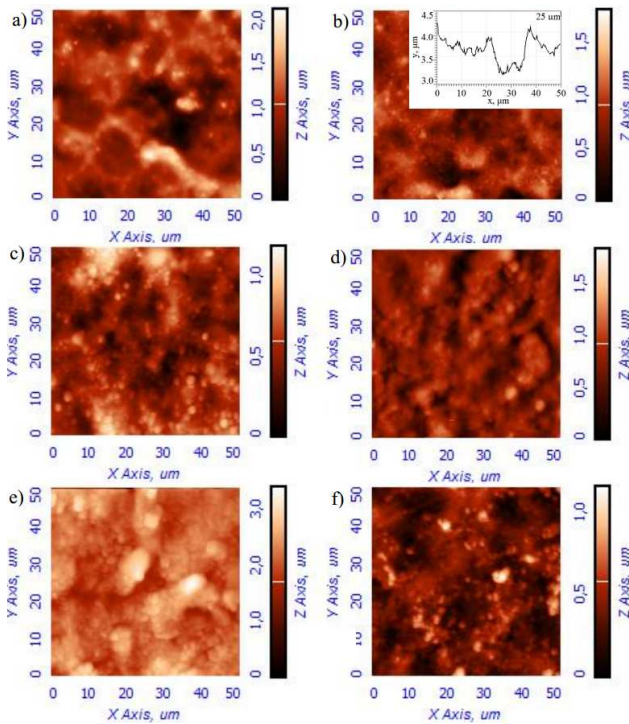


Fig. 2. AFM images of MgO thin films obtained at T_s [K]: 643 (a), 653 (b), 663 (c), 673 (d), 683 (e), and 693 (f). (Inset) A typical profile of the film surface obtained using AFM.

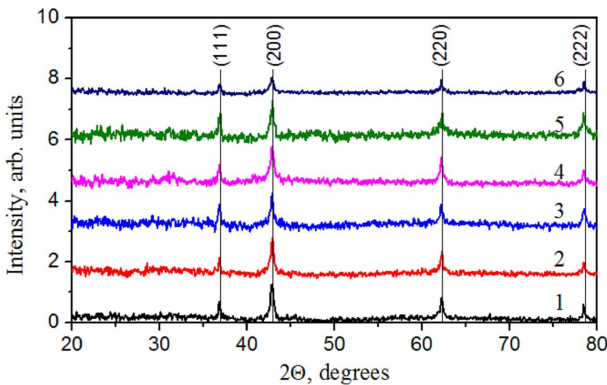


Fig. 3. X-ray diffraction patterns of MgO films deposited at substrate temperatures of T_s [K]: 643 (1), 653 (2), 663 (3), 673 (4), 683 (5), and 693 (6).

Figure 3 shows X-ray diffraction patterns of the MgO films deposited at different growth conditions. The X-ray patterns show peaks at $2\theta = 36.80^\circ$, 42.84° , 62.16° , and 78.44° , which are identified as reflections from the (111), (200), (220), and (222) planes of the cubic MgO phase [25] (JCPDS 01-075-0477). Reflection from crystallographic planes of other phases is not observed, which

indicates that the thin films are single phase. It should be noted that we detected hydroxyl compounds of magnesium, such as a $\text{Mg}_2(\text{OH})_3 \cdot \text{Cl}_4 \cdot \text{H}_2\text{O}$, by X-ray diffraction in films obtained at substrate temperatures below 643 K [15].

X-ray diffraction analysis showed that reflections from crystallographic (111) and (200) planes of the cubic phase of MgO are dominant, which indicates the presence of growth texture in the films. Further calculations of the pole density P_i and the orientation factor f (Table I) confirmed the presence of pronounced axial [111] growth texture of MgO layers. A similar growth texture was also observed in [26, 27]. It was found that the texture of films slightly improved with increased substrate temperature.

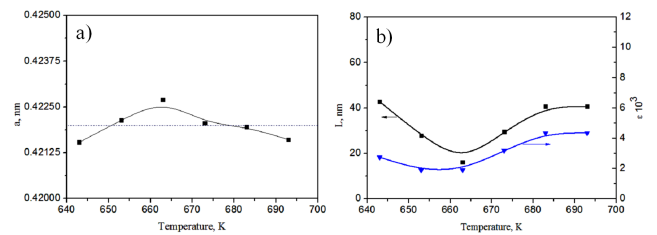


Fig. 4. Effect of substrate temperature on lattice constant a reference data (dashed line) (a) and CSD size L and level of microstrains ε (b) of MgO films.

The lattice constants were determined using the Nelson-Riley extrapolation method. The lattice constant of the MgO layers varied in the range from 0.42154 to 0.42270 nm. Their influence of substrate temperature on the lattice constant has a non-monotonic behavior (Fig. 4a). With the increase of the substrate temperature, we observed a gradual increase in the lattice constant, and then slight decrease. The values are all similar to the reference data ($a = 0.42200$ nm [25]).

Estimations of the substructural parameters of the films were carried out for the [111] direction of the crystal lattice of the cubic phase (by reflections from the (100) and (222) planes) by threefold convolution [24]. The results for dimensions of CSD and microstrains are shown in Fig. 4b and Table I.

It is shown (Fig. 4b) that increasing the substrate temperature of thin films leads to decrease of CSD from $L \sim 43$ nm ($T_s = 643$ K) to $L \sim 16$ nm ($T_s = 663$ K) in the [111] direction and then increase to $L \sim 41$ nm ($T_s = 693$ K). Similar values of CSD sizes ($L = 15$ nm) were obtained in [20] by using the Scherrer equation for magnesium oxide films deposited at temperatures of 673 K and 723 K from solutions of magnesium acetylacetonate as a precursor. Also, similar values of CSD of 16 nm were obtained in [11]. These authors synthesized films at a temperature range from $T_s = 673$ K to 873 K using magnesium acetate as a precursor in ethanol with HCl and TEG. Slightly larger values of CSD were found in compounds of A_2B_6 films deposited by close-spaced vacuum sublimation [28–31].

The dependence of microstrains on substrate temperature in the studied films (Fig. 4b) is similar to substrate temperature dependences of CSD. The microstrain of thin films decreases from 2.75×10^{-3} ($T_s = 643$ K) to $1.89 \sim 10^{-3}$ ($T_s = 653$ K) and then increases to 4.35×10^{-3} ($T_s = 693$ K).

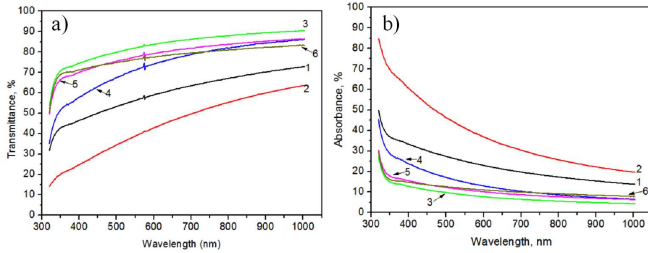


Fig. 5. Transmittance spectra (a) and absorbance spectra (b) of MgO thin films obtained at substrate temperature T_s [K]: 643 (1), 653 (2), 663 (3), 673 (4), 683 (5), and 693 (6).

Transmittance spectra of magnesium oxide films deposited on glass substrates are presented in Fig. 5a. The highest value of transmittance is obtained at substrate temperatures of $T_s = 663$ K and 683 K. The layers obtained at the lower temperatures show lowest values of transmittance (643 and 653 K). This is a good correlation with the literature data [2, 8, 20, 22, 32, 33]. The decrease in transmittance could be explained by the increased concentration of defects and the presence of additional grain boundaries.

The optical absorption coefficients (α) of these films were determined from the transmittance spectra using the Lambert equation

$$\alpha = \ln(1/T)/d,$$

where d is the film thickness and T is the transmittance [34]. It should be noted that reflection from the layers is not taken into account.

Figure 5b shows calculated absorbance spectra of magnesium oxide films. As expected the highest absorption is observed in films obtained at lower substrate temperatures. For determination of the optical band gap energy (E_g), we used the following equation, which is suitable for both direct and indirect band gap materials

$$\alpha h\nu = A(h\nu - E_g)^n,$$

where A is some constant that depends on the effective mass of charge carriers in the material, $h\nu$ is the energy of the photon, and n is a number that depends on the nature of the transition. In this case this value was found to be $1/2$ (which corresponds to a direct band-to-band transition).

Figure 6 shows the typical dependence of $(\alpha h\nu)^2$ versus $h\nu$ for the obtained MgO films. The intersection of the straight line with the $h\nu$ -axis gives the optical band gap energy E_g [35]. The corresponding results are present in Table I. The band gap energy of the films increases with substrate temperature in the range from 338 to 370 eV.

It should be noted that these values were significantly lower than the band gap of bulk MgO ($E_g = 73$ eV [2]). The observed optical band gap energy, therefore, corresponds not to the intrinsic band gap of MgO but to some below-band-gap optical transitions due to impurities, etc. The values ($E_g = 3.81$ – 3.92 eV) similar to ours were presented in [32]. In this study the magnesium oxide thin films were obtained by spin-coating using a 0.1 M Mg ion solution that was prepared by dissolving magnesium nitrate hexahydrate [$\text{Mg}(\text{NO}_3)_2 \cdot 6\text{H}_2\text{O}$] in ethanol [$\text{C}_2\text{H}_5\text{OH}$]. Nitric acid was then added to the solutions as a stabilizer. A much lower band gap energy value of $E_g = 2.5$ eV was reported in [22] for thin films obtained by spray pyrolysis. They used 0.05 M of magnesium chloride hexahydrate dissolved in deionized water as a precursor solution. A higher value of $E_g = 4.51$ eV was found for MgO nanowires synthesized by solvothermal method [36]. The values of the band gap in the range from 4.1 to 4.6 eV were found for nanoparticles obtained by chemical precipitation [37] and $E_g = 4.2$ eV for nanoparticles deposited by spray pyrolysis [38]. Larger band gap values found in these studies were attributed to the small size of nanoparticles.

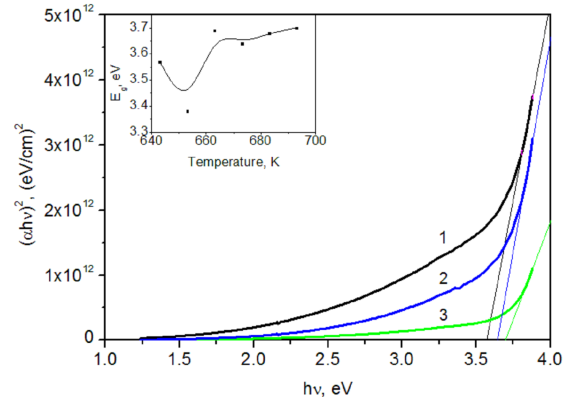


Fig. 6. Typical dependence $(\alpha h\nu)^2$ vs. $h\nu$ of MgO thin films obtained at T_s [K]: 643 (1), 673 (2), and 663 (3). Inset: dependence bandgap energy E_g vs. temperature T of MgO thin film.

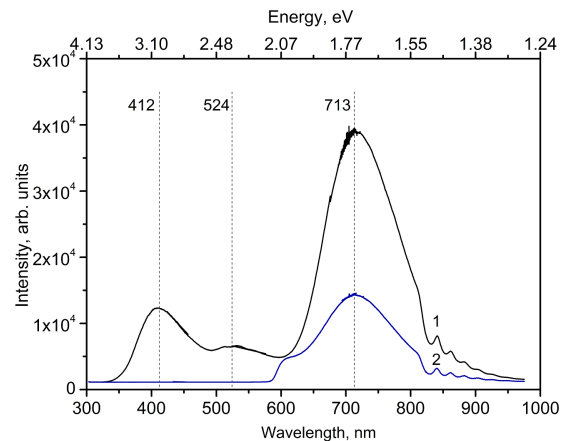


Fig. 7. Typical photoluminescence spectra of (1) MgO and (2) glass substrate.

The room-temperature photoluminescence (PL) spectra of magnesium oxide films are presented in Fig. 7. The PL spectra show emission peaks at approximately 412 nm (3.00 eV) and 524 nm (2.38 eV). The peak at 3.00 eV could be assigned to holes trapped on magnesium ion vacancies acting as acceptors (F^+ center). The broad emission peak at 524 nm is related to the presence of defects (F^- centers) associated with oxygen ion vacancies. These results are in good correlation with previous work [39–41]. In order to exclude the influence of the substrate, we also measured the PL spectrum of the glass substrate. As can be seen from Fig. 7, the peak at 713 nm on the MgO spectrum corresponds to a PL signal from the glass substrate, although its intensity is a bit higher.

4. Conclusion

Nanostructured magnesium oxide films have been obtained by a simple and effective spray pyrolysis method in the substrate temperature range of $T_s = 643$ K to 693 K. The magnesium chloride hexahydrate ($MgCl_2 \cdot 6H_2O$) aqueous solution was used as a precursor solution. It was established that MgO thin films have a single-phase, a cubic structure with a [111] growth texture. The lattice constant of the MgO layer varied in the range of $a = 0.42154$ nm to 0.42270 nm and slightly increased at the substrate temperatures of $T_s = 643$ –663 K. The CSD sizes in the MgO films and the microstrain in directions perpendicular to the crystallographic (111) planes were $L_{(111)} = 16.2$ –42.8 nm and $\varepsilon \approx (1.89$ –4.35) $\times 10^{-3}$, respectively. The films obtained at substrate temperatures higher than 663 K have quite a good transmittance (80–90%) in a wide wavelength range. The optical band gap values were found to be $E_g = 3.64$ –3.70 eV, which is much lower than the band gap of bulk material. The observed optical band gap of the films increased with the substrate temperature. The PL spectra show emission peaks at ≈ 412 nm (3.00 eV) and at ≈ 524 nm (2.38 eV), which were attributed to positively and negatively charged F^- centers. The MgO layers, obtained by spray pyrolysis in this work can be used as a window or a protective layer in solar cells and other optoelectronic devices, thanks to their high optical properties.

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